

APOS 2016

The 6th Asia Pacific Optical Sensors Conference
Oct. 11-14, 2016/ Shanghai, China

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Dear Ms Lee,

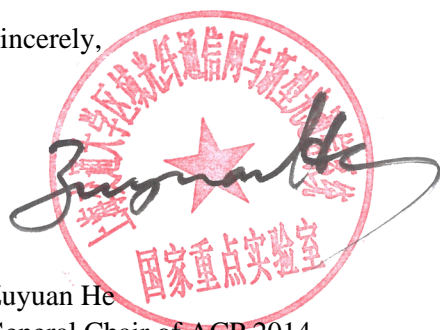
On behalf of the Program Committee of the **Asia Communications and Photonics Conference (ACP)**, I am sending you this letter to welcome your participation in the ACP 2014 conference, which is to be held 11-14 November 2014 in Shanghai, China at the Shanghai International Convention Center. The meeting is open to all Optical Society of America (OSA), Society of Photographic Instrumentation Engineers (SPIE), IEEE Photonics Society, IEEE Communications Society, Chinese Optical Society (COS), China Institute of Communications (CIC) members, and those with related optics interest.

Your participation in the meeting includes presenting your paper *Beyond-Nominal-Resolution Distributed Strain Sensing by Slope-Assisted Brillouin Optical Correlation-Domain Reflectometry*(Control number:2554027), attending sessions in your area of interest, and an opportunity to communicate with others working in the field of optical science.

This is an invitation to participate in the meeting but not a personal sponsorship of your stay in China. You will need to secure your own funding for travel, registration, and housing expenses for the meeting.

Additional meeting information, including visa requirements, is available on the ACP website at www.acp-conf.org. Thank you for your interest in the meeting and we look forward to seeing you in Shanghai.

Sincerely,



Zuyuan He
General Chair of ACP 2014
Professor, Shanghai Jiao Tong University